



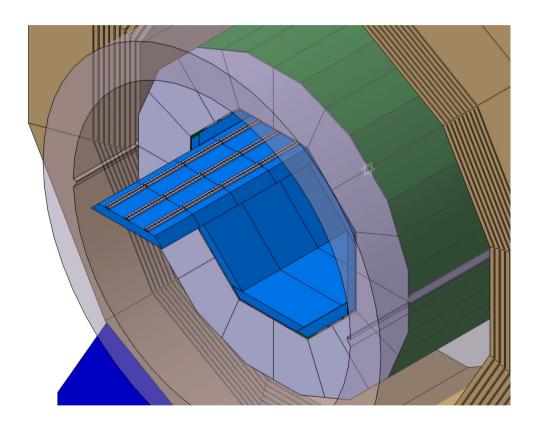
Status of Ecal(s) for ILD

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ILD Meeting at LCWS11 at Granada Sept. 2011

Subdetector components IV - Electromagnetic calorimeter

The SiW Ecal in the ILD Detector



Basic Requirements

- Extreme high granularity
- Compact and hermetic

Basic Choices

- Tungsten as absorber material
 - X0=3.5mm, RM=9mm. λI=96mm
 - Narrow showers
 - Assures compact design
- Silicon as active material or
- Scintillator as active material

Ecal designed as Particle Flow Calorimeter R&D within CALICE Collaboration

Detector Optimisation - Number of Layers/Sensitive Material

Models under study:

- 1) A pure SiW Ecal Calorimeter with 20 < N < 30 Layers
- 2) A pure Scintillator Ecal
- 3) A hybrid solution e.g. first 20 layers Si with rear part of calorimeter equipped with Scintillator

PFA studies for hybrid calorimeter ongoing

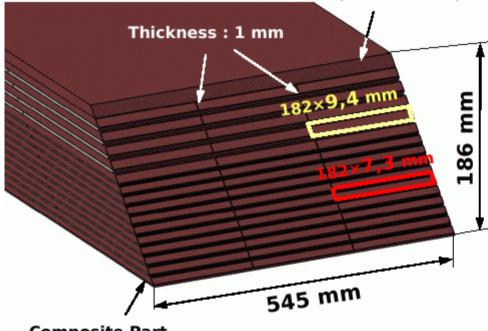
Both options are implemented into Mokka since long

- PFA with silicon well tested already for LOI
- PFA with scintillator is well advancing

Technological prototypes



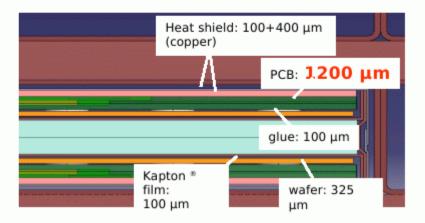
Composite Part with metallic inserts (15 mm thick)

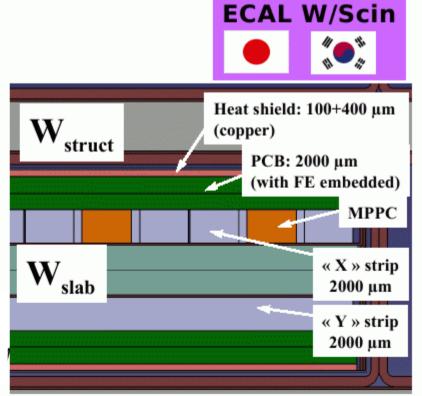


Composite Part (2 mm thick)

Technological prototype to address engineering challenges of detector Construction Collaboration between alternative

Collaboration between alternative technologies where possible ILD@LCWS11 Sept. 2011





R&D for Technological Readiness - Detectors

Scint Ecal SiW Ecal

- Proof of principle with physics prototypes
 Solid backup of full detector simulation by beam test data
- Robustness of calibration over 6 years (at least proven for SiW Ecal)
- Alveolar structures for barrel and end caps

First ASUs expected 2011/12

- Tests of electronics
- Test of power pulsing in magnetic field
- Interconnection and cooling
- → planned until summer 2012
- Scintillator strips seems to be available

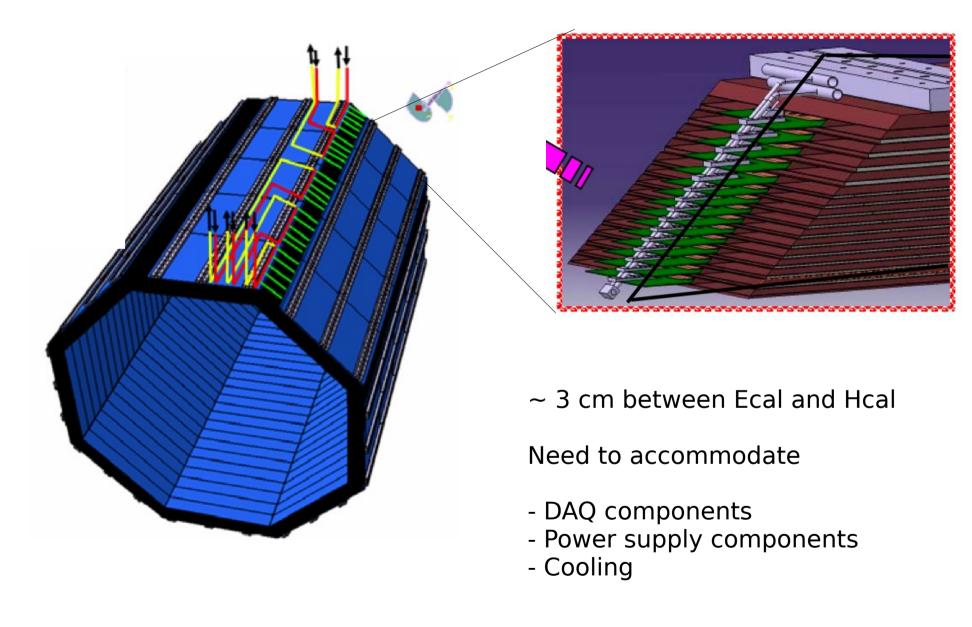
First ASUs since 2009

First tests in 2011!!!
Progress slowed down
By non-availability of
DAQ2 ←. drop our of
British groups

- Advanced Wafers
 Technology in principle at hand but still matter of R&D
- Advanced PCBs
 Ultra thin and Ultra flat

Not clear what can be achieved until time of DBD All is very much funding driven
Main sources are French in2p3/ANR and new Japanese ILC funding
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R&D for Technological Readiness - Peripherals

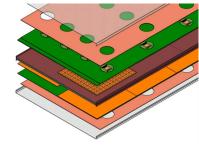


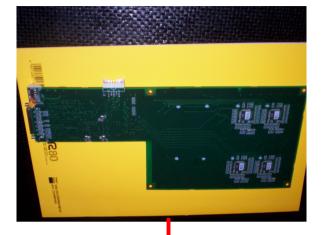
Issues are addressed and at least we will come up with a list of open issues and proposals how to address these

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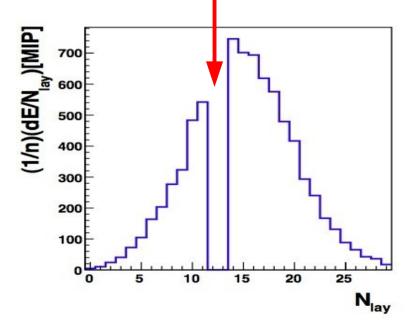
Embedded electronics - Parasitic effects?

Exposure of front end electronics to electromagnetic showers





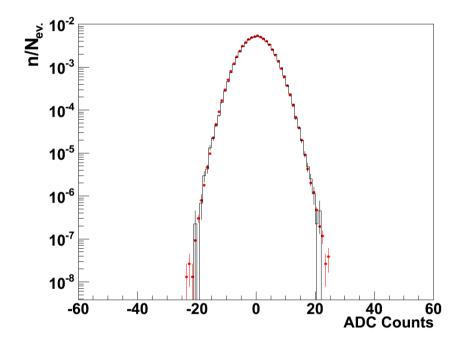
Chips placed in shower maximum of 70-90 GeV em. showers



Possible Effects: Transient effects
Single event upsets

Comparison: Beam events

(Interleaved) Pedestal events



- No sizable influence on noise spectra by beam exposure
 - Δ Mean < 0.01% of MIP Δ RMS < 0.01% of MIP
- No hit above 1 MIP observed
 - => Upper Limit on rate of faked MIPs: $\sim 7 \times 10^{-7}$

Summary of Ecals

- Ecals in s/w baseline
 Both Ecals are well implemented in Mokka
 Solid backup by beam test analyses
- Input for technology part of DBD

All relevant questions are addressed

However, anwers driven by available funding and manpower

- Some points are already achieved:
 - Stable calibration (at least demonstrated for SiW Ecal)
 - No negative impact by embedded electronics (goes beyond Ecal matters)
 - Large alveaolar structures are about to be constructed

Backup